

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	Yoichiro Ohta)
)
Serial No.:	10/796,344)
)
Conf. No.:	1978)
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Filed:	3/9/2004)
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For:	VACUUM PROCESSING)
	APPARATUS)
)
Art Unit:	1792)
)
Examiner:	Lund, Jeffrie Robert)

AMENDMENT F

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the final Office Action mailed December 23, 2008, please
amend the application as follows: